



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

T. Walsh

Application No: 10/008,635

Filed: December 4, 2001

For: PARALLEL ALIGNMENT METHOD AND
APPARATUS FOR CHEMICAL MECHANICAL
POLISHING

) Docket No: LAM2P232A

) Examiner: Nguyen, D.

) Group Art Unit: 3723

) Date: November 18, 2003

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REQUEST FOR CONTINUED EXAMINATION (RCE) TRANSMITTAL

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1. Submission required under 37 C.F.R. § 1.114

- a. ☒ Previously submitted
- i. ☒ Consider the amendment(s)/reply under 37 C.F.R. § 1.116 previously
filed on October 8, 2003.
- ii. ☐ Consider the arguments in the Appeal Brief or Reply Brief previously
filed on _____.
- iii. ☐ Other _____.
- b. ☐ Enclosed
- i. ☐ Amendment/Reply
- ii. ☐ Affidavit(s)/Declaration(s)
- iii. ☐ Information Disclosure Statement (IDS)
- iv. ☐ Other _____.

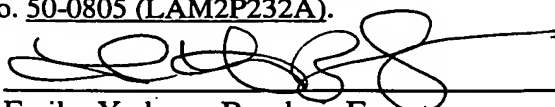
2. Miscellaneous

- a. ☐ Suspension of action on the above-identified application is requested under 37
C.F.R. § 1.103(c) for a period of _____ months.
- b. ☐ Other

3. Fees

- a. ☒ Check in the amount of \$880.00 _____ is enclosed for:
- i. ☒ RCE fee required under 37 C.F.R. § 1.17(e);
- ii. ☒ Extension of time fee (37 C.F.R. §§ 1.136 and 1.17); and
- iii. ☐ Other _____.
- b. ☒ The Director is hereby authorized to charge any fees, or credit any
overpayments, to Deposit Account No. 50-0805 (LAM2P232A).

Date: November 18, 2003

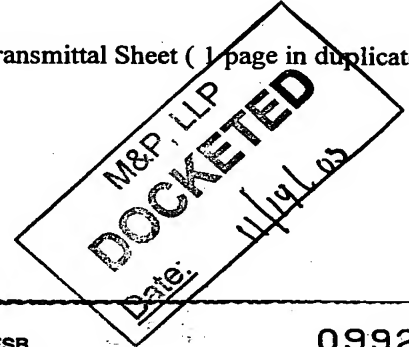

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Registration No. 53,805

PATENT POSTCARD-Continuation Number 25920

Docket No. LAM2P232A Appl. No.: 10/008,635 Date: Nov. 18, 2003
 By: CFY:kh Filing Date: Dec. 4, 2001 Express Mail No.:
 Inventor(s): Thomas WALSH
 Title: PARALLEL ALIGNMENT METHOD AND APPARATUS FOR CHEMICAL MECHANICAL POLISHING

The following has been received in the U.S. Patent & Trademark Office on the date stamped below:

- Request for Continued Examination (RCE) Transmittal Sheet (1 page in duplicate)
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Basic Filing Fee - RCE
 Extension Fees: 1 Month

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